



12/20/04

JPW

Attorney Docket No. 09792909-5921

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	Group Art Unit: 2811
)	
Jinichi SATO)	Examiner:
)	
Application No. 10/828,882)	
)	
Filed: April 21, 2004)	
)	
For: Semiconductor Thin Film and Method)	
of Fabricating Semiconductor Thin)	
Film, Apparatus for Fabricating Single)	
Crystal Semiconductor Thin Film, and)	
Method of Fabricating Single Crystal)	
Thin Film, Single Crystal Thin Film)	
Substrate and Semiconductor Device)	

Mail Stop Missing Parts
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Mail Stop Non-Fee Amendments
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Prior to examination of the above-referenced continuation patent application,
Applicants request entry of the following amendments and remarks.